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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

**P**pplicant

Yamagishi, et al.

App. No.

10/072,620

Filed

8 February 2002

For

**SEMICONDUCTOR** 

PROCESSING APPARATUS COMPRISING CHAMBER PARTITIONED INTO

REACTION AND

TRANSFER SECTIONS

Examiner

Dean J. Kramer

Art Unit

3652

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## **AMENDMENT AFTER FINAL**

Sir

In response to the Final Office Action mailed on 22 September 2004, please enter the amendments and consider the remarks presented herein.

## **Introductory Comments**

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 7 of this paper.